



## AMENDMENT / RESPONSE TRANSMITTAL

Applicant : Sophie et al.  
 App. No. : 09/975,466  
 Filed : October 9, 2001  
 For : IN SITU REDUCTION OF  
 COPPER OXIDE PRIOR TO  
 SILICON CARBIDE  
 DEPOSITION  
 Examiner : Kielin  
 Art Unit : 2813

## CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 10, 2003

(Date)

Andrew N. Merickel, Reg. No. 53,317

 TECHNOLOGY CENTER 2800  
 OCT 17 2003

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

Response to Office Action in 2 pages.

The fee has been calculated as shown below:

FEE CALCULATION					
FEES TYPE		FEES CODE	CALCULATION		TOTAL
Total Claims	21 - 32 = 0	1202 (\$18)	0	x 18 =	\$0
Independent Claims	2 - 4 = 0	1201 (\$84)	0	x 84 =	\$0
Multiple Claim		1203 (\$280)			\$0
1 Month Extension		1251 (\$110)			\$0
2 Month Extension		1252 (\$410)			\$0
3 Month Extension		1253 (\$930)			\$0
			TOTAL FEE DUE		\$0

Return prepaid postcard.

RECEIVED

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



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